Active vibration control of a beam with piezoelectric patches: real-time implementation with xPC target

Conference Paper - July 2003
DOI 10.1109/CCA.2003.1225494 - Source: IEEE Xplore

3 authors, including:

Momoh Salami
International Islamic University Malaysia
140 PUBLICATIONS 932 CITATIONS

Md Raisuddin Khan
International Islamic University Malaysia
103 PUBLICATIONS 276 CITATIONS

Some of the authors of this publication are also working on these related projects:

- Design and Development of MR damper dispersion system View project
- Development of ANN based technique for TVAR parameter estimation View project
Active Vibration Control of a Beam with Piezoelectric Patches: Real-time Implementation with xPC target

Asan Gani, M.J.E. Salami-SMIEEE and Md. Raisuddin Khan

Abstract—Active control of a vibrating beam using smart materials such as piezoelectric materials is examined in this paper. A model based on Euler-Bernoulli beam equation has been developed and then extended with bonded three piezoelectric patches which act as sensor, actuator and exciter. The sensor and actuator are collocated to achieve a minimum phase. The aim of this research work is to control the first three resonant modes. To achieve this, a compensated inverse PID controller is developed and tuned to damp these modes using MATLAB. The designed controller for damping each mode is then combined in parallel to damp any of the three modes. Finally, the simulation results are verified experimentally and the real-time implementation is carried out with xPC target toolbox in MATLAB.

Index Terms—Smart Materials, Piezoelectric sensor/actuator, Vibration suppression, Inverse PID, xPC, MATLAB

I. INTRODUCTION

The ability to monitor and control vibration is vital in achieving the desired objectives of many engineering systems, such as automobiles, aerospace, and precision machining and this list could continue. Advances in smart materials have shown an increased interesting application of smart materials for passive and active structural damping. Advancements in smart material technology have produced much smaller actuators and sensors with high integrity in structures. There are significant works in progress to reduce structural vibration. Passive damping treatment has fixed frequency range and adds significant weight to the structures. To overcome these drawbacks piezoelectric materials have been advocated for use in order to have control over a wide range of frequencies without adding much weight to the structure. Research in piezoelectric materials is rapidly gaining attention in many developed countries and it is envisaged that such technology will widen the scope and enhanced the quality of products in manufacturing industries.

Vibration control using Piezoelectric materials can be accomplished either passively (with shunt circuit) [1]-[3] or actively. In shunt circuit techniques, the main role of piezoelectric material is to dissipate energy. This is achieved when mechanical work is done on an element and some portion of it is converted to and stored as dielectric energy. In a vibrating structure, a shunt network can be configured to accomplish vibration control by modifying the dynamics of the electrical system [4], [5]. This system is analogous to mass-spring damper system which acts as a vibration absorber. A properly tuned shunt circuit can add significant damping to a structure. In active control, an external power is applied to a piezoelectric material to produce a force in opposite direction to that produced by vibrating structure at a particular position. The opposite forces will cancel each other and thus reduce its vibration. In this paper, a compensated inverse PID controller is designed to reduce multiple vibration modes of structures. The controller also reduces the 'spillover' effect which is caused by the presence of uncontrollable or unmodeled modes within the bandwidth of the closed loop system.

In this paper piezoelectric materials act as an actuator and a sensor for vibration control of flexible a structure. The results of active control for the first three resonant modes are presented. The controller developed for each mode is tested individually and later combined in parallel to control any of the three modes. The performance of the combined controller is discussed and a comparison is made between the individual and combined controller.

II. EULER-BERNOLLLI BEAM MODEL: MODAL ANALYSIS

In this section, mathematical models for Euler beam as a continuous system and with collocated piezoelectric sensor and actuator are developed. Various transfer functions for use in simulation studies are developed in detail.

A. Lateral Vibration of beam

![Fig. 1. Lateral vibration of beam](image-url)
Inertia force acting on beam = \( \rho A(x) \frac{\partial^2 z(x,t)}{\partial t^2} \) where \( \rho \) = mass density, \( A(x) \) = cross sectional area and \( \rho \beta A(x) \) = mass per unit length. Considering the equation of motion along the \( x \)-axis and the moment around \( y \)-axis at \( 0 \) leads to:

\[
-(V' + dV') + f(x,t)dx + V = \rho A(x) \frac{\partial^2 z(x,t)}{\partial x^2}
\]

\[ (M + \frac{dM}{dt}) - M - (V' + dV')dx + f(x,t)dx = 0 \]

Taking \( dV = \frac{1}{2}V' + dV' \) and \( M = \frac{M}{2} \), then equation becomes:

\[
\frac{\partial^2 M}{\partial x^2}(x,t) + f(x,t) = \rho A(x) \frac{\partial^2 z(x,t)}{\partial t^2}
\]

Equation (3) can be rewritten as:

\[
E(x) \frac{\partial^2 z(x,t)}{\partial x^2} + \rho A(x) \frac{\partial^2 z(x,t)}{\partial t^2} = f(x,t)
\]

B. Model of beam with bonded piezoelectric patches

Fig. 2 shows the position of the attached piezoelectric patch on beam. The piezoelectric actuator’s dimension is as shown in the figure and a voltage \( V_0(t) \) is applied to it.

Assuming the beam is a one dimensional system, equation (5) becomes:

\[
E(x) \frac{\partial^2 z(x,t)}{\partial x^2} + \rho A(x) \frac{\partial^2 z(x,t)}{\partial t^2} = \frac{\partial M_a(x,t)}{\partial t}
\]

To incorporate the placement of the piezo patch on the beam surface in \( x \) direction, Heaviside Step function is employed, so that the finite length of actuator, (7) can be written as:

\[
M = KV_0(t) \left[ H(x-x_1) - H(x-x_2) \right]
\]

Substituting \( z(x,t) = \sum w_i(x)q_i(t) \) and (8) in (6) yields:

\[
\frac{\partial^2 q_i(t)}{\partial t^2} + \omega_i^2 q_i(t) = -\frac{KV_0(t)}{\rho A(x)} \left( w_i(x_2) - w_i(x_1) \right)
\]

The transfer function that describes the elastic deflection of the entire beam due to an applied voltage to the actuator is given in (11). Incorporating a proportional damping term [7] to (11) gives:

\[
U_{in}(s) = z(x,s) = \sum_{i=1}^{n} \frac{K}{s^2 + \omega_i^2} \left[ w_i(x_2) - w_i(x_1) \right] V_0(s)
\]

C. Transfer functions for simulation studies

Taking the Laplace transform of equation (9) gives:

\[
q_i(s) = \frac{KV_0(t)}{\rho A(x)} \left( w_i(x_2) - w_i(x_1) \right)
\]

Since, \( z_i(x,s) = w_i(x)q_i(t) \) equation (10) becomes:

\[
z_i(x,s) = \frac{w_i(x)KV_0(t)}{\rho A(x)\left( s^2 + \omega_i^2 \right)} V_0(s)
\]

The total charge accumulated on the sensing layer can be found by integrating \( q(x,t) \) over the entire surface area of the piezo sensor and that is given by:

\[
Q(t) = \int_{x_1}^{x_2} q(x,t)dx = -w_i \left[ \frac{h_2 + h_1}{2} \right] \frac{k_{ij}^2 \partial^2 (x_i)_{ij}}{g_{ij}}
\]

Charged piezoelectric patches can be considered as a parallel plate capacitor, the voltage across the layer will be:

\[
V_i(t) = \frac{Q(t)}{C_{pj}(x_2 - x_1)} = C_{pj} \frac{\partial^2 (x_i)_{ij}}{\partial t^2}
\]

Where \( C_{pj} \) is the patch capacitance and \( x_2-x_1 \) is the length of piezo sensor and \( C_{pj} \) is:

\[
C_{pj} = \frac{h_2 + h_1}{2} \frac{k_{ij}^2}{g_{ij}}
\]
Taking the Laplace transform of (15) gives

\[ V(s) = \frac{C \sum_{j=1}^{n} \left( w_j(x_2) - w_j(x_1) \right) \left[ w'_j(x_2) - w'_j(x_1) \right]}{\rho l^4 \sum_{j=1}^{n} \left( w_j(x_2) - w_j(x_1) \right)^2} \]

which can be written as

\[ G_{sens}(s) = \frac{V(s)}{V_e(s)} = \frac{C \sum_{j=1}^{n} \left( w_j(x_2) - w_j(x_1) \right) \left[ w'_j(x_2) - w'_j(x_1) \right]}{\rho l^4 \sum_{j=1}^{n} \left( w_j(x_2) - w_j(x_1) \right)^2} \]

(16)

3) Piezoelectric exciter voltage vs. piezoelectric sensor voltage and beam deflection: Fig. 3, shows the piezoelectric exciter's location on the beam, where the applied force \( F(x,t) \), which depends on the applied voltage \( V_e(t) \), is used to excite the piezoelectric patch.

![Fig. 3 Location of piezoelectric exciter on beam](image)

From (10), the sensor voltage output for applied exciter voltage is given by

\[ V(s) = C \sum_{j=1}^{n} \frac{K \left( w_j(x_4) - w_j(x_3) \right) \left[ w'_j(x_4) - w'_j(x_3) \right]}{\rho l^4 \left( \xi^2 + 2\zeta_i \omega_i + \omega_i^2 \right)} \]

resulting in

\[ G_{sens}(s) = \frac{V(s)}{V_e(s)} = C \sum_{j=1}^{n} \frac{K \left( w_j(x_4) - w_j(x_3) \right) \left[ w'_j(x_4) - w'_j(x_3) \right]}{\rho l^4 \left( \xi^2 + 2\zeta_i \omega_i + \omega_i^2 \right)} \]

(17)

\[ G_{sens}(s) = \frac{V_s(x,s)}{V_e(s)} = \frac{C \sum_{j=1}^{n} \left( w_j(x_4) - w_j(x_3) \right) \left[ w'_j(x_4) - w'_j(x_3) \right]}{\rho l^4 \left( \xi^2 + 2\zeta_i \omega_i + \omega_i^2 \right)} \]

(18)

\[ G_{sens}(s) = \frac{Z(x,s)}{V_e(s)} = \frac{C \sum_{j=1}^{n} \left( w_j(x_4) - w_j(x_3) \right) \left[ w'_j(x_4) - w'_j(x_3) \right]}{\rho l^4 \left( \xi^2 + 2\zeta_i \omega_i + \omega_i^2 \right)} \]

(19)

III. CONTROLLER DESIGN AND SIMULATION RESULTS

A. Block diagram for beam with attached piezoelectric patches

The structure of the closed loop system of the beam attached with piezoelectric sensor and actuators is shown in Fig. 5 and Fig. 6. In Fig. 6, an extra transfer function \( G_{sens}(s) \) is introduced to transfer tip displacement to piezoelectric sensor voltage output. This is necessary since the reference input is in voltage.

![Fig. 5 Block diagram with feedback control for piezoelectric Sensor (V_e(s))](image)

![Fig. 6 Block diagram with feedback control for beam deflection (Z(x,s))](image)

The actuator voltage \( V_a(s) \) is \( V_a(s) = [V_e(s) - V_a(s)]C(s) \). The block diagram reduction for Fig. 5 and Fig. 6 lead to the close loop transfer functions as follows;

\[ V_a(s) = \frac{G_{sens}(s)V_e(s)}{1 + C(s)G_{sens}(s)} \]

(20)

\[ Z(x,s) = \frac{G_{sens}(s)V_e(s)}{1 + C(s)G_{sens}(s)} + \frac{C(s)G_{sens}(s)Z(x,s)}{1 + C(s)G_{sens}(s)} \]

(21)

since \( G_{sens}(s) = G_{sens}(s)G_{sens}(s) \) (21) is reduced to

\[ Z(x,s) = \frac{G_{sens}(s)V_e(s)}{1 + C(s)G_{sens}(s)} + \frac{C(s)G_{sens}(s)Z(x,s)}{1 + C(s)G_{sens}(s)} \]

(22)

It is desired to have \( V_a(s) = 0 \) and the role of the controller is only to eliminate the effects of the disturbace force \( F(x,t) \). Since a piezoelectric actuator is used as an exciter, the input force is controlled by its voltage \( V_e(s) \). With \( V_e(s) = 0 \), diagram in Fig. 5 reduced to Fig. 7 and transfer functions (20) and (21) can also be simplified.

![Fig. 7 Block diagram with feedback control for sensor output when V_a(s)=0](image)

B. Controller design

The proposed controller in this paper is ‘compensated inverse PID’ or denoted as CIPID that takes the following form. The subscript ‘\( i \)’ stands for number of modes. The controller is developed by taking into consideration the effect of truncated modes which might cause the spillover effects \([9],[10]\). Hence the controller is designed to attenuate first three modes so that

\[ C_i(s) = \sum_{j=1}^{3} \frac{1}{s^2 + K_p s + K_i} \left( K_p s + K_i \right) \]

(25)

where \( K_p, K_i \) and \( K_0 \) are respectively the gains of the PID and these are tuned to damp i-th mode, where \( \omega_i \) is the resonant frequency for i-th mode, that is

\[ \omega_i = \frac{2 \zeta_i \omega_i}{K_p} \]

(26)

Using superposition rules, the CIPID controller can be extended to control first three modes as given in (25). The controller for each mode will be arranged in parallel. Basically the CIPID is used to damp the resonant peaks by placing poles at each resonant frequency. Changing \( K_p \) in the above equation will change the damping factor for each mode and can control the resonant peak. However higher damping factor doesn’t mean that the peak will be always reduced; hence an optimal value of \( K_p \) is required for each mode. Fig. 8, shows the controller and beam with bonded piezoelectric. A digital
lowpass filter is applied to sensor output to remove any interference signal or noise.

Fig. 8. Controller and beam bonded with piezoelectric patches

C. Simulation results

The ability of the above controller in damping the resonant modes is investigated here. Different values of $K_P$, $K_I$, and $K_D$ are taken to study their effects on the resonant modes. Initial simulation is carried out for the individual modes and the individual controllers are combined to damp all the three modes. In order to get more realistic simulation results, the damping factors and modes frequencies used for simulations in equations (12), (16), (18) and (19) are taken from the experimental results. The experimental damping ratios and mode frequencies are shown in Table 1.

Table I

<table>
<thead>
<tr>
<th>Modes</th>
<th>Frequency</th>
<th>$\zeta$ (damping ratio)</th>
</tr>
</thead>
<tbody>
<tr>
<td>1</td>
<td>11.14</td>
<td>0.02027</td>
</tr>
<tr>
<td>2</td>
<td>66.74</td>
<td>0.01021</td>
</tr>
<tr>
<td>3</td>
<td>186.64</td>
<td>0.00320</td>
</tr>
</tbody>
</table>

In this simulation studies, the value of $K_D$ is chosen to be 1, $K_I$ is taken from equation (26) and $K_P$ is adjusted by taking different values of $zeta$ in equation (26). The simulation is carried out by changing the value of $K_P$, which correspondingly varies the damping ratio of the controller. The optimal values of $K_P$ can then be obtained. The results obtained for resonant peak reductions for $V_i$ are summarized in Table II.

Table II

<table>
<thead>
<tr>
<th>Zeta</th>
<th>First Mode</th>
<th>Second Mode</th>
<th>Third Mode</th>
</tr>
</thead>
<tbody>
<tr>
<td>10</td>
<td>222.82</td>
<td>3.33</td>
<td>0.4</td>
</tr>
<tr>
<td>5</td>
<td>111.41</td>
<td>5.6</td>
<td>1.9</td>
</tr>
<tr>
<td>1</td>
<td>22.282</td>
<td>14.61</td>
<td>3.4</td>
</tr>
<tr>
<td>0.5</td>
<td>11.141</td>
<td>18.676</td>
<td>5</td>
</tr>
<tr>
<td>0.1</td>
<td>22.282</td>
<td>15.121</td>
<td>11.46</td>
</tr>
<tr>
<td>0.01</td>
<td>0.2228</td>
<td>14.08</td>
<td>18.38</td>
</tr>
</tbody>
</table>

This table shows maximum reduction for the first mode at $zeta = 0.5$ or $K_P = 11.141$. Smaller values of $zeta$ cause undesirable shift of the resonant frequency and introduce new peaks at the neighborhood of the actual frequency. For the second mode, greater reduction is achieved with $zeta = 0.01$. However, this value introduces new peak on the left side of the resonant frequency, hence the most suitable value of $K_P$ is 2.2282. For the third mode, lower damping values increase the resonant peak, instead of reducing it, hence the best result is achieved with $K_P = 11.141$.

IV. EXPERIMENTAL SETUP AND DATA ACQUISITION SYSTEM

This section discusses the instruments, data acquisition systems and software used for implementation of active vibration control in real-time. Properties of hardware are also discussed in detail. An aluminum beam is used to carry out the experiment. The properties of the beam are given in Table III.

Table III

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Value</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>Length, L</td>
<td>0.5</td>
<td>m</td>
</tr>
<tr>
<td>Width, w</td>
<td>0.04</td>
<td>m</td>
</tr>
<tr>
<td>Thickness, h</td>
<td>0.003</td>
<td>m</td>
</tr>
<tr>
<td>Modulus of Young, $E$</td>
<td>$6.9 \times 10^8$</td>
<td>N/m²</td>
</tr>
<tr>
<td>Area Moment of Inertia, I</td>
<td>$9 \times 10^{-11}$</td>
<td>m⁴</td>
</tr>
<tr>
<td>Density, $\rho$</td>
<td>2700</td>
<td>kg/m³</td>
</tr>
<tr>
<td>Area, A</td>
<td>$1.2 \times 10^{-4}$</td>
<td>m²</td>
</tr>
</tbody>
</table>

Three ACX piezoelectric patches are used in this research. Two unimorph patches model QP10W are collocated and used as sensor and actuator. One bimorph patch model QP25N is used as an exciter. Their properties are given in Table IV.

Table IV

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Value</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>Length, $L_p$</td>
<td>45.974</td>
<td>mm</td>
</tr>
<tr>
<td>Width, $w_p$</td>
<td>33.274</td>
<td>mm</td>
</tr>
<tr>
<td>Height, $h_p$</td>
<td>0.254</td>
<td>mm</td>
</tr>
<tr>
<td>Capacitance</td>
<td>0.1</td>
<td>F</td>
</tr>
<tr>
<td>Coupling Coefficient, $k_{11}$</td>
<td>0.3</td>
<td>0.4</td>
</tr>
<tr>
<td>Elastic Modulus, $E_{31}$</td>
<td>$6.9 \times 10^{10}$</td>
<td>Pa</td>
</tr>
<tr>
<td>Elastic Modulus, $E_{11}$</td>
<td>$5.5 \times 10^{10}$</td>
<td>Pa</td>
</tr>
<tr>
<td>Charge Coefficient, $d_3$</td>
<td>$-179 \times 10^{-12}$</td>
<td>m/V</td>
</tr>
</tbody>
</table>

The piezoelectric exciter is placed at the middle of the beam. While the piezoelectric actuator and sensor are collocated near the fix end of the beam. The transfer function of a collocated sensor-actuator has minimum phase due to pole-zero interlacing [11], [12]. To add the most damping, the piezoelectric patch is bonded on the structure in the area of highest strain energy. It is as been reported in [3], [14] that the highest strain energy for first three modes is at clamped boundary of the cantilever beam. Reference [14] showed that analytical equation can be used accurately to predict the optimum position of piezoelectric. The piezoelectric sensor and actuator are attached at about 15 mm from the clamped end of the beam.

Two linear power amplifiers are used in this setup. Both amplifiers have a gain up to 20 and output voltage of ±200V.
A Keyence laser displacement sensor model LK-081 is used to measure the beam tip displacement. National instruments (NI) data acquisition card model PCI-MIO-16XE-10 is used to acquire analog signal from the piezoelectric sensor. Control signal is sent to piezoelectric actuator through output channel of the card. A four channel HP-Dynamic signal analyzer (DSA) model HP-35670A, is used to obtain beam resonant frequencies and respective damping ratios. Controlled and uncontrolled responses of the beam are measured and analyzed using the DSA.

Real-time implementation is carried out using xPC Target toolbox in MATLAB. It is a high-performance, host-target prototyping environment that enables the connection of Simulink models to physical systems and execute them in real-time on PC-compatible hardware [15]. xPC target enables to add I/O blocks to Simulink models, automatically generate code with Real-time Workshop, and download the code to a second PC running the xPC Target real-time kernel.

V. EXPERIMENTAL RESULTS
In this section we will experimentally verify the controllers' performances. Early results have shown the individual controller performance in damping respective modes. Thereafter the controller is combined to damp all the three modes. The experimental results of this combined controller are discussed toward the end of this section.

A. First mode controller's performance

The beam is excited at its first resonant frequency which is 11.141 Hz in order to test the controller ability in damping this mode. Fig. 10(a) and Fig. 10(b) are showing the gain of \( G_{vcw} \) and piezoelectric sensor output \( V_s \) respectively under controlled and uncontrolled conditions.

Fig. 10(a): Controlled and uncontrolled gain for \( G_{vcw} \) at first mode

Fig. 10(b): piezoelectric sensor output for first mode

Fig. 11(a) shows the reduction in gain of \( G_{vcw} \) while Fig. 11(b) shows in reduction in peak-peak beam tip displacement upon switching on the controller.

Fig. 11(a): controlled and uncontrolled gain for \( G_{vcw} \) at first mode

Fig. 11(b): Peak-peak displacement of beam tip at first mode
The first mode controller’s performance is summarized in Table V:

<table>
<thead>
<tr>
<th>Gvev (V/V)</th>
<th>Vs (volt)</th>
<th>Gvev (mm/V)</th>
<th>z (mm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Uncontrolled</td>
<td>1.2496</td>
<td>7.472</td>
<td>0.24960</td>
</tr>
<tr>
<td>Controlled</td>
<td>0.1765</td>
<td>0.878</td>
<td>0.01987</td>
</tr>
<tr>
<td>Reduction</td>
<td>1.073</td>
<td>6.594</td>
<td>0.27993</td>
</tr>
<tr>
<td>Reduction (dB)</td>
<td>17.80</td>
<td>18.60</td>
<td>22.00</td>
</tr>
<tr>
<td>Reduction (%)</td>
<td>92.05</td>
<td>58.88</td>
<td>88.28</td>
</tr>
</tbody>
</table>

B. Second mode controller’s performance

The beam is excited at 66.744 Hz to produce second resonant mode. The controller’s ability to damp second mode is demonstrated in Fig. 12 and 13. Fig. 12 shows the reduction in gain for $G_{vew}$.

![Fig. 12: Controlled and uncontrolled gain for $G_{vev}$ at second mode](image)

![Fig. 13: Controlled and uncontrolled gain for $G_{vev}$ at second mode](image)

The peak reduction for second mode is shown in Table VI:

<table>
<thead>
<tr>
<th>Gvev (V/V)</th>
<th>Vs (volt)</th>
<th>Gvev (mm/V)</th>
<th>z (mm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Uncontrolled</td>
<td>0.02583</td>
<td>0.0921</td>
<td>0.00209</td>
</tr>
<tr>
<td>Controlled</td>
<td>0.02374</td>
<td>0.0695</td>
<td>0.00283</td>
</tr>
<tr>
<td>Reduction</td>
<td>0.00209</td>
<td>0.0226</td>
<td>0.73287</td>
</tr>
<tr>
<td>Reduction (%)</td>
<td>8.10</td>
<td>24.54</td>
<td></td>
</tr>
</tbody>
</table>

C. Third mode controller’s performance

The performance of third mode controller is shown in Fig. 14. The beam is excited at 186.6 Hz.

![Fig. 14: Controlled and uncontrolled gain for $G_{vev}$ at third mode](image)

The peak reduction for third mode is shown in Table VII:

<table>
<thead>
<tr>
<th>Gvev (V/V)</th>
<th>Vs (volt)</th>
<th>Gvev (mm/V)</th>
<th>z (mm)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Uncontrolled</td>
<td>0.02283</td>
<td>0.0921</td>
<td>0.00209</td>
</tr>
<tr>
<td>Controlled</td>
<td>0.02374</td>
<td>0.0695</td>
<td>0.00283</td>
</tr>
<tr>
<td>Reduction</td>
<td>0.00209</td>
<td>0.0226</td>
<td>0.73287</td>
</tr>
<tr>
<td>Reduction (%)</td>
<td>8.10</td>
<td>24.54</td>
<td></td>
</tr>
</tbody>
</table>

D. Combined controller’s performance

Individual mode controllers are combined in parallel to form a new combined controller. The performance of this combined controller is discussed in this section. The beam is excited with sweep sine signal over frequency range of 3 to 203 Hz, which comprises first three resonant mode frequencies. The controlled and uncontrolled transfer function $G_{uww}$ and $G_{uvw}$ are shown in Fig. 15 and Fig. 16 consecutively.

![Fig. 15: Controlled and uncontrolled gain for $G_{vev}$ for first three modes](image)

![Fig. 16: Controlled and uncontrolled gain for $G_{vev}$ for first three modes](image)
The summary of peak reduction for combined controller is given in Table VIII. The third mode for $g_{ave}$ is not visible due to negligibly small gain.

<table>
<thead>
<tr>
<th>TABLE VIII</th>
<th>PERFORMANCE OF THE COMBINED CONTROLLER</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>Gvez (mm/P)</td>
</tr>
<tr>
<td>mode</td>
<td>1st</td>
</tr>
<tr>
<td>Uncontrolled</td>
<td>0.2584</td>
</tr>
<tr>
<td>Controlled</td>
<td>0.0191</td>
</tr>
<tr>
<td>Reducation</td>
<td>0.2394</td>
</tr>
<tr>
<td>Reduction (dB)</td>
<td>22.65</td>
</tr>
<tr>
<td>Reduction (%)</td>
<td>92.63</td>
</tr>
</tbody>
</table>

Table IX shows the reduction in dB for first, second and third modes under the effects of individual and combined controller.

<table>
<thead>
<tr>
<th>TABLE IX</th>
<th>REDUCTION FOR INDIVIDUAL AND COMBINED CONTROLLER</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>Individual controller</td>
</tr>
<tr>
<td>mode</td>
<td>Gvez (mm/P)</td>
</tr>
<tr>
<td>1st</td>
<td>22.00</td>
</tr>
<tr>
<td>2nd</td>
<td>10.78</td>
</tr>
<tr>
<td>3rd</td>
<td>-</td>
</tr>
</tbody>
</table>

VI. CONCLUSION

This paper has discussed the use of piezoelectric materials to control the vibration of a beam. A novel controller that is based on inverse PID has been designed and used to achieve this objective. The results of the real-time implementation of the controller using xPC target are found to be very close to that of simulation studies which actually demonstrates the effectiveness of this technique. In general, the combined controller has shown a better performance for $g_{ave}$ for the first mode while it slightly produces poorer performance for the second mode as compared to the performance of the individual controller. However for $g_{ave}$ the individual controller has shown greater overall performance over the combined controller for all three modes. The drop in the performance for combined controller is likely due to the coupling effects and further research work on this aspect is under investigation.

REFERENCES